

Table I-7 to Subpart I of Part 98—Default Emission Factors (1-U_{ij}) for Gas Utilization Rates (U_{ij}) and By-Product Formation Rates (B_{ijk}) for PV Manufacturing

Process type factors	Process Gas i								
	CF ₄	C ₂ F ₆	CHF ₃	CH ₂ F ₂	C ₃ F ₈	c-C ₄ F ₈	NF ₃ Remote	NF ₃	SF ₆
	*	*	*	*	*	*	*		
CVD Chamber Cleaning 1-U _i	NA	0.6	NA	NA	0.1	0.1	NA	0.3	0.4
CVD Chamber Cleaning BCF ₄	NA	0.2	NA	NA	0.2	0.1	NA	NA	NA

Notes: NA = Not applicable; i.e., there are no applicable default emission factor measurements for this gas. This does not necessarily imply that a particular gas is not used in or emitted from a particular process sub-type or process type.